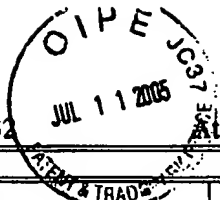


09/802,632



SN: 09/802,632

Atty. Docket# 50P4112.01

Page 2

U.S. PATENT DOCUMENTS						
Examiner Initial	Document Number	Date	Name	Class	Sub-Class	Filing Date
ll	6,745,223	06/2004	Nobakht et al.	709	200	
	5,940,073	08/17/1999	Klosterman et al.	345	327	
	6,240,555 B1	05/29/2001	Shoff et al.	725	110	
	5,977,964	11/1999	Williams et al.	715	721	
	5,929,849	07/1999	Kikinis, Dan	725	113	
	6,526,577	02/2003	Knudson et al.	725	40	
	6,756,997	06/2004	Ward et al.	715	716	
	6,066,565 6005565	12/1999	Legall et al.	715	721	
	6,029,195	02/22/2000	Herz	709	219	
	2002/0088004A1	07/04/2002	Kitsukawa	725	110	
	2002/0157108A1	10/24/2002	Kitsukawa	725	109	
	2002/0144258A1	10/03/2002	Kitsukawa	725		
	2002/0144288A1	10/03/2002	Kitsukawa	725		
	6,374,404 B1	04/16/2002	Brotz et al.	725	46	
	6,326,982 B1	12/04/2001	Wu et al.	345	718	
	6/367,080 B1	04/02/2002	Enomoto et al.	725	112	
	2002/0088004A1	07/04/2002	Kitsukawa	348		

28
10/31/07

FOREIGN PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES OR NO
ll	WO 98/56188	12/10/1998	Europe	H04N	7/173	Yes
	WO 97/42763	11/13/1997	Europe	H04N	7/173	
	CN 1236524A		China - cited in Chinese Patent Application, copy provided by Chinese Patent Office.	H04N	7/173	No
	WO 02/087239A1	10/31/2002	Europe	H04N	7/16	
	WO 02/086691A1	10/31/2002	Europe	G06F	3/00	
	EP 1 039 399 A1	12/30/1999	Europe	G06F	17/30	
	WO 02/087220A2	10/31/2002	Europe	H04N		
	WO 02/19689A2	03/07/2002	Europe	H04N	7/173	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	

Examiner *ll*

Date Considered 9/17/07

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